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***Optical System Alignment,
Tolerancing, and Verification III***

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Richard N. Youngworth
Editors

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Contents

- vii *Conference Committee*
- ix *Introduction*
- xi *Optical design dependence on technology development (Plenary Paper) [7428-01]*
I. A. Neil, ScotOptix (Switzerland)

SESSION 1 JWST AND LARGE OPTICS

- 7433 02 **Presentation, analysis, and simulation of active alignment strategies for the James Webb Space Telescope [7433-01]**
R. S. Upton, Space Telescope Science Institute (United States)
- 7433 03 **Optomechanical integration and alignment verification of the James Webb Space Telescope (JWST) optical telescope element (Invited Paper) [7433-02]**
C. Wells, M. Coon, ITT Space Systems Division (United States)
- 7433 04 **Optical metrology of the JWST Integrated Science Instrument Module test platform [7433-03]**
J. M. Stock, Stinger Ghaffarian Technologies, Inc. (United States); J. A. Connelly, M. D. Nowak, NASA Goddard Space Flight Ctr. (United States); G. W. Wenzel, K. W. Redman, QinetiQ North America, Inc. (United States)
- 7433 05 **Updates to the optical alignment and test plan for the James Webb Space Telescope integrated science instrument module (Invited Paper) [7433-04]**
R. Ohl, NASA Goddard Space Flight Ctr. (United States)
- 7433 06 **Trades for ambient non-contact metrology [7433-05]**
R. Ohl, NASA Goddard Space Flight Ctr. (United States); B. Hoffmann Eegholm, Space Telescope Science Institute (United States); M. Casas, Metris USA (United States); B. Frey, M. Dominguez, NASA Goddard Space Flight Ctr. (United States); J. Gill, QinetiQ North America/Mission Solutions Group (United States); J. Hayden, Sigma Space (United States); P. Morken, Metris USA (United States); K. Redman, V. Roberts, QinetiQ North America/Mission Solutions Group (United States); B. Saif, Space Telescope Science Institute (United States); T. Scirpo, Metris USA (United States)
- 7433 07 **Development of a dual field of view optical system for an uncooled IR camera [7433-06]**
H. K. Kim, C. M. Ok, J. K. Park, Topins Corp. (Korea, Republic of); H. D. Cheong, Hanbat National Univ. (Korea, Republic of)

SESSION 2 ALIGNMENT AND ASSOCIATED ABERRATIONS OF OPTICAL SYSTEMS

- 7433 08 **An alignment procedure for multi-element precision cylinder lenses and modular enclosure to house them** [7433-07]
J. P. Lehan, Univ. of Maryland (United States) and NASA Goddard Space Flight Ctr. (United States); G. Byron, R. McClelland, NASA Goddard Space Flight Ctr. (United States) and SGT, Inc. (United States); T. Hadjimichael, NASA Goddard Space Flight Ctr. (United States) and Ball Aerospace (United States); R. Russell, NASA Goddard Space Flight Ctr. (United States) and SGT, Inc. (United States); D. Robinson, NASA Goddard Space Flight Ctr. (United States)
- 7433 09 **Alignment challenges for optomechanical engineers (Invited Paper)** [7433-08]
A. E. Hatheway, Alson E. Hatheway, Inc. (United States)
- 7433 0A **Alignment aberrations of the New Solar Telescope** [7433-09]
A. M. Manuel, J. H. Burge, College of Optical Sciences, The Univ. of Arizona (United States)
- 7433 0B **Using nodal aberration theory to understand the aberrations of multiple unobscured three mirror anastigmatic (TMA) telescopes** [7433-10]
K. P. Thompson, Optical Research Associates (United States); K. Fuerschbach, Univ. of Rochester (United States); T. Schmid, College of Optics & Photonics, Univ. of Central Florida (United States); J. P. Rolland, Univ. of Rochester (United States) and College of Optics & Photonics, Univ. of Central Florida (United States)
- 7433 0C **Alignment of off-axis optical system with multi mirrors using derivative of Zernike polynomial coefficient** [7433-11]
Y. Kim, H.-S. Yang, Univ. of Science and Technology (Korea, Republic of) and Korea Research Institute of Standards and Science (Korea, Republic of); S.-W. Kim, Yonsei Univ. (Korea, Republic of); Y.-W. Lee, Korea Research Institute of Standards and Science (Korea, Republic of)

SESSION 3 TOLERANCING METHODS AND APPLICATIONS

- 7433 0D **Tolerancing panoramic lenses** [7433-12]
J. Parent, S. Thibault, Laval Univ. (Canada)
- 7433 0E **The cost of tolerancing** [7433-13]
J. DeGroot Nelson, Optimax Systems, Inc. (United States); R. N. Youngworth, Light Capture, Inc. (United States); D. M. Aikens, Savvy Optics Corp. (United States)
- 7433 0F **A six sigma review of miniature optics alignment** [7433-14]
J. Tesar, Novadaq Technologies, Inc. (United States)
- 7433 0G **Tolerance compensation in micro-optics** [7433-15]
I. Sieber, M. Dickerhof, Forschungszentrum Karlsruhe GmbH (Germany); A. Schmidt, Univ. Karlsruhe (Germany)
- 7433 0H **Tolerancing Forbes aspheres: advantages of an orthogonal basis** [7433-16]
R. N. Youngworth, Light Capture, Inc. (United States)

SESSION 4 DESIGN, DEVELOPMENT, AND VERIFICATION OF OPTICAL SYSTEMS

- 7433 OI **Toroidal variable-line-space gratings: the good, the bad, and the ugly** [7433-17]
E. West, NASA Marshall Space Flight Ctr. (United States); K. Kobayashi, The Univ. of Alabama in Huntsville (United States); J. Cirtain, NASA Marshall Space Flight Ctr. (United States); A. Gary, The Univ. of Alabama in Huntsville (United States); J. Davis, NASA Marshall Space Flight Ctr. (United States); J. Reader, National Institute of Standards and Technology (United States)
- 7433 OL **Design, assembly, and testing of a high-resolution relay lens used for holography with operation at both doubled and tripled Nd:YAG laser wavelengths** [7433-20]
R. M. Malone, G. A. Capelle, B. C. Cox, B. C. Frogget, M. Grover, M. I. Kaufman, National Security Technologies, LLC (United States); P. Pazuchanics, D. S. Sorenson, Los Alamos National Lab. (United States); G. D. Stevens, A. Tibbitts, W. D. Turley, National Security Technologies, LLC (United States)
- 7433 OM **The design and alignment of the DECAM lenses and modelling of the static shear pattern and its impact on weak lensing measurements** [7433-21]
M. Antonik, P. Doel, D. Brooks, S. Bridle, Univ. College London (United Kingdom); T. Abbot, Cerro Tololo Inter-American Observatory (Chile); R. Bernstein, B. Bigelow, Univ. of California Observatories (United States); H. Cease, Fermi National Accelerator Lab. (United States); D. L. DePoy, Texas A&M Univ. (United States); B. Flaughner, Fermi National Accelerator Lab. (United States); M. Gladders, Univ. of Chicago (United States); G. Gutierrez, S. Kent, A. Stefanik, Fermi National Accelerator Lab. (United States); A. Walker, Cerro Tololo Inter-American Observatory (Chile); S. Worswick, Consultant (United Kingdom)
- 7433 ON **From design to assembly: getting the most from your optical software** [7433-22]
M. G. Turner, J. A. Herlocker, Breault Research Organization (United States)

POSTER SESSION

- 7433 OP **Pupil alignment reference (PAR) for the Mid-Infrared Instrument (MIRI) for optical alignment and verification on the Integrated Science Instrument Module (ISIM) in James Webb Space Telescope (JWST)** [7433-24]
C. Aymergen, P. Driggers, SGT, Inc. (United States); R. Ohl IV, R. Lundquist, P. Davila, B. Bos, S. Antonille, D. Kubalak, NASA Goddard Space Flight Ctr. (United States); S. Le, Ball Aerospace & Technologies Corp. (United States); L. Hanssen, NIST (United States); V. Mikula, C. Hakun, C. Guishard, J. Guzek, J. Connelly, NASA Goddard Space Flight Ctr. (United States); J. McMann, Qinetiq North America (United States)

Author Index

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- 1 JWST and Large Optics
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- 2 Alignment and Associated Aberrations of Optical Systems
Raymond G. Ohi IV, NASA Goddard Space Flight Center (United
States)
Mitchell C. Ruda, Ruda and Associates, Inc. (United States)
- 3 Tolerancing Methods and Applications
Maria D. Nowak, NASA Goddard Space Flight Center (United States)
Craig Olson, L-3 Communications Sonoma EO (United States)
- 4 Design, Development, and Verification of Optical Systems
Chao-Wen Liang, National Central University (Taiwan)
Richard N. Youngworth, Light Capture, Inc. (United States)

Introduction

The 2009 Optical System Alignment, Tolerancing, and Verification conference ended up being a turning point as the community showed a significant increase both in submitting papers and in attending the sessions. The audience made it obvious that the conference fills an important need and that the topics are current and useful.

The conference had a diverse mixture of papers covering a variety of interesting topics. Papers ranged from research through applications, indicating various stages of development of alignment, tolerancing, and verification in our discipline. One strong highlight of the conference was the series of James Webb Space Telescope (JWST) papers where expert authors showed the community JWST alignment plans and methodologies. These papers are very welcome and appreciated as they cover some of the very difficult challenges and solutions that program is producing. In addition to the offerings related to JWST, the conference had papers covering fundamental alignment aberrations and studies, papers related to tolerancing of various optical systems, and a host of papers showing advances in a number of applications.

We thank the authors for sharing their expertise, the audience for attending the conference, and SPIE for providing an excellent conference forum. We look forward to continuing this conference next year and making it as beneficial as possible for the optics and photonics community.

José Sasian
Richard N. Youngworth

